

QUERY CONTROL FORM			RTIS USE ONLY		
Application No.	10/081 439	Prepared by	BGU	Tracking Number	5931401
Examiner-GAU	WILLE-284	Date	5/11/04	Week Date	4/5/04
		No. of queries	1	IFW (RU4)	

JACKET

a. Serial No.	f. Foreign Priority	k. Print Claim(s)	<input checked="" type="checkbox"/> PTO-1449
b. Applicant(s)	g. Disclaimer	l. Print Fig.	<input type="checkbox"/> q. PTOL-85b
c. Continuing Data	h. Microfiche Appendix	m. Searched Column	<input type="checkbox"/> r. Abstract
d. PCT	i. Title	n. PTO-270/328	<input type="checkbox"/> s. Sheets/Figs
e. Domestic Priority	j. Claims Allowed	o. PTO-892	<input type="checkbox"/> t. Other

SPECIFICATION

- a. Page Missing
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- f. Duplicate Text
- g. Brief Description
- h. Sequence Listing
- i. Appendix
- j. Amendments
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CLAIMS

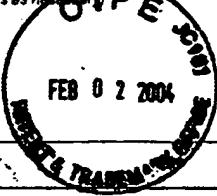
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Thank You

initials *BG*

RESPONSE

initials

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <small>(Use as many sheets as necessary)</small>		<small>Complete if Known</small>				
		Application Number	10/081439			
		Filing Date	February 20, 2002			
		First Named Inventor	Ahn, Kie			
		Group Art Unit	2818			
		Examiner Name	Unknown			
Sheet 1 of 2		Attorney Docket No: 1303.046US1				

US PATENT DOCUMENTS

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		Application Number 10/081439	Filing Date February 20, 2002
		First Named Inventor Ahn, Kie	Group Art Unit 2818
		Examiner Name Unknown	Attorney Docket No: 1303.046US1
Sheet 2 of 2		Attorney Docket No: 1303.046US1	

FOREIGN PATENT DOCUMENTS

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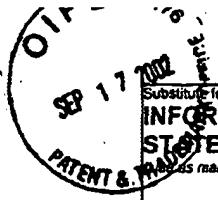
Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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PTO/SB/056 (10-01)
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Application Number	10/081439
Filing Date	February 20, 2002
First Named Inventor	Ahn, Kie
Group Art Unit	2818
Examiner Name	Unknown

Sheet 1 of 1

Attorney Docket No: 01303.046US1

US PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
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